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APPLICANT: Gerlach, Tesch, Martin,  
Skoczylas and Procyk

EXAMINER: Not Assigned

FILING DATE: 10/17/2001

TITLE: "Focused Ion Beam System"

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TC 2800 MAIL ROOM  
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TRANSMITTAL

Assistant Commissioner for Patents  
Washington, D.C. 20231

In connection with the above-identified application, applicant submits the following:

1. Information Disclosure Statement
2. Form 1449
3. One reference

Respectfully submitted,

Date: 2/20/02

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CERTIFICATE OF MAILING

I hereby certify that this paper or fee is being deposited with the United States Postal Service as first-class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231, on the 20th day of February, 2002

By:   
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